

DOCKET NO: 283485US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
MASATOMO SUMIYA, ET AL. : EXAMINER: LEONG, NATHAN T.  
SERIAL NO: 10/562,265 :  
FILED: MAY 24, 2006 : GROUP ART UNIT: 1792  
FOR: METHOD FOR GROWING THIN :  
NITRIDE FILM ONTO SUBSTRATE AND  
THIN NITRIDE FILM DEVICE

AMENDMENT AND REQUEST FOR CONTINUED  
EXAMINATION (RCE) UNDER 37 C.F.R. § 1.114

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Official Action dated July 27, 2009, reconsideration is respectfully requested in the above-identified application in view of the following amendments and remarks submitted in conjunction with a Request for Continued Examination (RCE):

**Amendments to the Claims** begin on page 2 of this response.

**Support for the Amendments** begin on page 4 of this response.

**Remarks** begin on page 5 of this response.